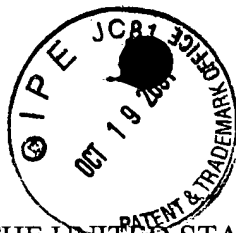


S/N 09/208105



#2010  
2-5-02  
R. Shadler  
N.E.  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SAKAMOTO

Examiner:

O. Nadav

Serial No.: 09/208105

Group Art Unit:

2811

Filed: November 25, 1998

Docket No.:

10233.81USW1

Title: SEMICONDUCTOR DEVICE AND A METHOD FOR MANUFACTURING THEREFORE

RECEIVED  
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**CERTIFICATE UNDER 37 CFR 1.10:**

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By:

  
Name: Chris Stordahl

**AMENDMENT UNDER RULE 116**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the official action, dated May 15, 2001, please amends this application as follow:

**In the Specification**

Please amend the specification to read as follow:

Please replace the paragraph beginning at page 8 line 5, with the following rewritten paragraph:

--resist layer 82 is formed above both the crystal--

Please replace the paragraph beginning at page 8 line 10, with the following rewritten paragraph:

--the silicon oxidation layer 27 is formed above the crystal--